

22 **To harness the intriguing properties of two-dimensional van der Waals (vdW)**
23 **ferromagnets (FMs) for versatile applications, the key challenge lies in the reliable material**
24 **synthesis for scalable device production. Here, we demonstrate the epitaxial growth of single-**
25 **crystalline 1T-CrTe₂ thin films on 2-inch sapphire substrates. Benefiting from the uniform surface**
26 **energy of the dangling bond-free Al₂O₃(0001) surface, the layer-by-layer vdW growth mode is**
27 **observed right from the initial growth stage, which warrants precise control of the sample**
28 **thickness and atomically smooth surface morphology across the entire wafer. Moreover, the**
29 **presence of the Coulomb interaction at the CrTe₂/Al₂O₃ interface serves as an effective tuning**
30 **parameter to tailor the anomalous Hall response, and the structural optimization of the CrTe₂-**
31 **based spin-orbit torque device leads to a substantial switching power reduction by 54%. Our**
32 **results may lay out a general framework for the design of energy-efficient spintronics based on**
33 **configurable vdW FMs.**

34

35 Featured by the inherent long-range magnetic order and a high-degree of magnetism tunability under
36 external stimuli, the discovery of two-dimensional (2D) van der Waals (vdW) ferromagnets (FMs) has
37 brought about a new platform for the advancement of energy-efficient non-volatile spintronics^{1,2}. In the
38 meanwhile, the weak inter-layer vdW force would facilitate the hetero-integration between 2D FMs and
39 other materials with different physical orders, hence greatly broadening the functionalities of the
40 associated device applications^{3,4}. To obtain high-quality 2D FMs with aforementioned characteristics,
41 the most frequently-adopted synthetic methods are the mechanical and electrochemical transfer
42 techniques (*i.e.*, the so-called top-down method), where a-few-layer flakes are exfoliated from their bulk
43 crystals^{1,2,5}. Although it seems to be cost-effective and straightforward, this approach inevitably suffers
44 from low productivity, small sample size, and limited thickness/orientation controllability^{1,5,6}. To

45 comply with the mass-production prerequisite, alternative bottom-up methods, such as the chemical
46 vapor deposition (CVD)⁷, the seeded growth⁸ and dual-coupling-guided growth⁹, are developed to
47 fabricate large-size vdW FMs. However, the 2D FMs grown via chemical reaction under the equilibrium
48 condition would follow the Wulff construction which constantly leads to the edge-induced nucleation
49 and the formation of self-limited triangular or hexagonal islands¹⁰⁻¹². Even though dedicated surface
50 treatments have recently been introduced to permit uniform nucleation^{8, 9, 11, 12}, the high growth rate
51 would make the film thickness control challenging. As a result, the layer-dependent electronic/magnetic
52 properties of vdW FMs and the opportunities to implement their heterostructure/superlattice in
53 spintronics remain elusive.

54 In this work, we report the wafer-scale growth of uniform CrTe₂ thin films and Bi₂Te₃/CrTe₂
55 heterostructures by molecular beam epitaxy (MBE). Owing to its low-energy physical deposition nature
56 and non-equilibrium growth dynamics¹³⁻¹⁵, MBE ensures high homogeneity with atomic-scale surface
57 roughness in the grown 2-inch samples, and the vdW layer-by-layer growth mode empowers us with the
58 ability to finely tune the film thickness across the 2D-to-bulk regions. Together with the *ab initio*
59 calculation of electronic band structure, we unveil that the quantum confinement and interfacial effects
60 in the ultra-thin CrTe₂ film would effectively modify its Berry curvature and magnetic order strength,
61 triggering the polarity change of the resulting anomalous Hall signal. Furthermore, by combining the
62 ferromagnetic CrTe₂ with the topological insulators Bi₂Te₃, we realize the spin-orbit torque (SOT)-
63 driven magnetization switching in the integrated vdW heterostructures with a high endurance of more
64 than 5×10^4 read-write cycles, and the manageable thickness of the CrTe₂ layer offers an additional
65 degree of freedom for tailoring the performance of the SOT devices.

66

67 **Wafer-scale epitaxial growth of vdW FM CrTe₂ thin films.** Experimentally, 2-inch Al₂O₃(0001)
68 wafers were chosen as the substrate. The absence of dangling bonds at the substrate surface and the
69 weak bonding energy between CrTe₂ and Al₂O₃ guarantee a uniform surface energy distribution, which
70 in turns promotes the van der Waals epitaxial growth of CrTe₂^{16,17}. Accordingly, a sharp reflection high-
71 energy electron diffraction (RHEED) streaky pattern develops already for the first layer, and the spacing
72 between the two first-order reciprocal lattice rods in **Fig. 1a** corresponds to an in-plane lattice constant
73 of $a = 3.84 \text{ \AA}$, in agreement with expected 1T-CrTe₂ data¹⁸. Further, high-resolution transmission
74 electron microscopy (TEM) (**Fig. 1b**) shows an intact, layered crystalline structure with abrupt van der
75 Waals gaps, and within each constituent layer, the Cr (pink spheres) and Te (yellow spheres) atoms
76 rigorously follow the Te-Cr-Te Z-shaped stacking configuration, validating the 1T phase of the as-grown
77 CrTe₂ sample⁷.

78 Next, we conducted atomic force microscope (AFM) measurements in order to examine the
79 conformity of the CrTe₂ film, and **Fig. 1c** illustrates one dataset of the 9 monolayer (ML) sample with
80 two noticeable features. First of all, in contrast to μm -size triangular or hexagonal terraces (*i.e.*, as they
81 would stem from the island nucleation process) observed in conventional vdW 2D materials^{19,20}, the
82 AFM mapping of the CrTe₂ film shows quite uniform nucleation and homogeneous atomic-scale surface
83 morphology (*i.e.*, the root-mean-square roughness $R_q = 3.68 \text{ \AA}$ is much less than the height of one CrTe₂
84 ML), which may take advantages of both the surface energy reduction (*i.e.*, owing to the vdW gap at the
85 CrTe₂/Al₂O₃ interface) and the long diffusion length of the adatoms¹¹. Secondly, the histogram of R_q
86 collected from 36 different areas exhibits a normal distribution with a narrow standard deviation of $3\sigma =$
87 0.28 \AA , hence manifesting the high uniformity across the whole 2-inch wafer (Supplementary Section
88 1).

89 In terms of film crystallinity, **Fig. 1d** displays the X-ray diffraction (XRD) results of five MBE-
90 grown CrTe₂ samples with thicknesses (d) ranging from 9 to 33 ML. It can be clearly seen that in
91 addition to the substrate signal, all spectra display only a series of CrTe₂ ($00n$) diffraction peaks without
92 any impurity phase within the instrument detection limit, and the extracted out-of-plane lattice parameter
93 $c = 6.10 \text{ \AA}$ is consistent with the $1T$ -CrTe₂ structure as well. Strikingly, **Fig. 1e** reveals identical
94 normalized CrTe₂ (002) Ω -scan curves with negligible mosaicity broadening (*i.e.*, no misorientation of
95 crystallites) compared with the Al₂O₃ (0006) reference line-shape, and the full width at half maximum
96 (FWHM) of $0.037^\circ \pm 0.001^\circ$ is among the narrowest values reported for vdW films²⁰⁻²². Besides, the
97 pronounced Kiessig fringes observed in the X-ray reflection (XRR) data in **Fig. 1f** not only quantify the
98 film thickness, but also attest the layer-by-layer epitaxial growth mode and low interlayer roughness of
99 the CrTe₂ samples. In conclusion, our comprehensive structural characterizations confirm the high
100 quality and reproducibility of the wafer-scale $1T$ -CrTe₂ thin films, therefore offering a solid foundation
101 for reliable device applications.

102

103 **Tunable anomalous Hall response driven by temperature and dimensionality.** To determine the
104 magnetic properties of the epitaxial $1T$ -CrTe₂ thin films, we fabricated mm-scale six-probe Hall bar
105 devices on the 2-inch wafers (**Fig. 2a**), and performed magneto-transport measurements at low
106 temperatures. **Figure 2b** exemplifies the characteristic anomalous Hall effect (AHE) on a 14 ML CrTe₂
107 sample, where the nearly square-shaped R_{xy} hysteresis loop and a butterfly-type double-split magneto-
108 resistance (MR) curve highlight the well-established spontaneous magnetization at $T = 10 \text{ K}$. Likewise,
109 the strong perpendicular magnetic anisotropy (PMA) of the films is also verified by the element-specific
110 X-ray magnetic circular dichroism (XMCD) hysteresis loops recorded at the Cr L_3 absorption edge,
111 confirming that the magnetism originates from the Cr atoms (Supplementary Section 2). As visualized in

112 **Fig. 2c**, the XMCD loop exhibits the same behavior as the AHE one as a function of the applied
113 magnetic field, which identifies that the ferromagnetism evolves together with the anisotropy of the
114 orbital moment²³.

115 Given that the reduced dimensionality can help to modify the electronic band structure and
116 magnetic properties of vdW 2D FMs^{1, 2, 5, 24}, we subsequently conducted systematic magneto-electric
117 transport measurements on three CrTe₂ samples with $d = 5, 9,$ and 14 MLs. Remarkably, the AHE
118 results show a distinct thickness-dependent trait. As evidenced in **Fig. 2d1-d3**, the coercive field H_C
119 decreases from 1.17 T (14 ML) to 1.15 T (9 ML) and 0.98 T (5 ML) at $T = 1.5$ K, and this evolution
120 trend suggests the weakening of the magnetism with reduced dimensionality. More importantly, the
121 AHE hysteresis loop reverses its polarity from negative to positive when the thickness is reduced to 5
122 ML. Similarly, such a negative-to-positive transition behavior of the AHE polarity is also observed in
123 the bulk-type 14 ML and 9 ML CrTe₂ samples during the warming-up process, yet the corresponding
124 transition temperature T^* is reduced from 115 to 70 K (*i.e.*, in contrast, the AHE sign remains to be
125 positive in the 2D-limit 5 ML thin film regardless of the base temperature).

126 To understand this dimensionality- and temperature-induced anomalous Hall response, we applied
127 density-functional theory (DFT) calculations to elaborate the underlying physics²⁵⁻²⁸. In particular, by
128 introducing the on-site Coulomb potential U correction to account for the correlation effects from the Cr
129 d -orbitals^{29, 30}, the theoretical derived Hall conductivity σ_{xy} is found to be positive in the monolayer
130 CrTe₂ system (**Fig. 3a**) and its sign changes to negative in the bulk case (**Fig. 3b**), reproducing the
131 observed thickness-dependent AHE polarity-reversal. To quantify this low-dimensional effect, we
132 conducted systematic investigations by varying the Coulomb potential amplitudes in both the monolayer
133 and the bulk CrTe₂ systems. As outlined in **Fig. 3c**, the negative σ_{xy} of the bulk form (*i.e.*, with periodic
134 boundary condition) shows little variation with respect to U . On the contrary, once the film thickness

135 enters the 2D domain, the itinerant electrons in the few-layer channel are subject to a confined out-of-
136 plane degree of freedom, and they naturally possess lower kinetic energy than those in the bulk region.
137 Under such circumstances, the potential energy U created by the Coulomb repulsion effectively
138 increases, which thereafter modulates the Berry curvature near the Fermi level (**Fig. 3a**) and leads to a
139 σ_{xy} sign-reversal. Along with the experimental observations (**Figs. 2d1-d3**), the DFT simulations
140 elucidate critical influence of the interface-related effect on tailoring the electronic geometry and AHE
141 response in the 2D CrTe₂ system.

142 Likewise, we can attribute the temperature-dependence of the anomalous Hall resistance in the thick
143 CrTe₂ samples (*i.e.*, $d \geq 9$ ML) to the modulation of Berry curvature associated with the magnetization
144 change^{28, 31}. Specifically, the diminished magnetic moment at elevated temperatures may bring about a
145 re-distribution of electronic states and switch the AHE polarity below a critical value of M_C (*i.e.*, above a
146 characteristic transition temperature T^*)³¹, given that the Berry curvature is highly sensitive to the
147 occupied density of states near the Fermi level. Following the same scenario, as the overall
148 magnetization is gradually suppressed in the thinner films, it is expected that the 9 ML CrTe₂ sample
149 would reach M_C at a lower transition temperature T^* compared to the 15 ML counterpart. In the ultra-
150 thin film case (*i.e.*, $d = 5$ ML) where the saturated magnetic moment is always smaller than M_C , its
151 temperature-invariant positive AHE response is therefore in line with that of the bulk-type CrTe₂ system
152 in the high-temperature region.

153

154 **Energy-Efficient SOT switching in Bi₂Te₃/CrTe₂ heterostructures.** Spin-orbit-torque (SOT) has been
155 utilized for next-generation magnetic random-access memory (MRAM) technology, owing to its low
156 power consumption and logic-programmable capability^{32, 33}. Considering that the SOT-driven
157 magnetization switching is determined by the charge-to-spin conversion efficiency, it has been

158 discovered that topological quantum materials (*e.g.*, topological insulators, Weyl/Dirac semimetals), in
159 which the intrinsic spin-orbit coupling (SOC) is strong enough to cause band inversion, can enable
160 sufficient current-induced spin polarization along the surface/edge states through the spin-momentum
161 locking mechanism^{34, 35}. Apart from the spin current channel, the magnetic strength in the adjacent FM
162 layer is another key factor to affect the switching current level. In this regard, the tunable magnetism
163 identified in our low-dimensional CrTe₂ samples, assuming that they can be incorporated into a SOT
164 structure, could afford more flexibility for optimizing the device performance.

165 Accordingly, to fully explore the potential of CrTe₂ for SOT-MRAM applications, we adopted the
166 same vdW growth procedure to prepare Bi₂Te₃/CrTe₂ heterostructures by MBE (*i.e.*, in order to make a
167 fair comparison, the top Bi₂Te₃ layer thickness is fixed to 18 nm in all samples investigated in this
168 work). As shown in **Fig. 4a**, the ultra-smooth CrTe₂ surface and the *in-situ* integration process in the
169 ultra-high vacuum environment result in the formation of a sharp hetero-interface, and the energy
170 dispersive X-ray (EDX) spectroscopy images ascertain the uniform element distribution without
171 observable inter-layer diffusion (Supplementary Section 3). After sample growth, standard 2D cross-bar
172 device arrays were fabricated on the 2-inch Bi₂Te₃/CrTe₂ wafers (**Fig. 4b**), and the relevant CrTe₂-
173 thickness-dependent current-driven magnetization switching results are presented in **Fig. 4c**. Guided by
174 the schematic diagram in **Fig. 4a**, the presence of a constant in-plane field $B_x = +0.09$ T sets up the
175 initial magnetization state of the sample in the (+*x*, +*z*) quadrant, and the applied DC current I_{DC} along
176 the $\pm x$ -direction dictates the effective spin-orbit field $\mathbf{B}_{SO} = \lambda_{SO} \cdot I_{TI} \cdot \boldsymbol{\sigma} \times \mathbf{M}$ (where λ_{SO} is the
177 coefficient characterizing the SOC strength, I_{TI} is the charge current component conducting through the
178 Bi₂Te₃ channel, and $\boldsymbol{\sigma} = \mp \sigma_y \cdot \hat{\mathbf{y}}$ is the electron spin accumulated at the Bi₂Te₃/CrTe₂ interface).
179 Consequently, as the DC current is successively scanned from +25 to -25 mA, the measured Hall
180 resistances R_{xy} (blue circles in **Fig. 4c**) all retain at constant values until the positive-to-negative

181 transitions occur in the large negative I_{DC} domains (*i.e.*, the parallel $(+B_x, +I_{DC})$ configuration stabilizes
 182 the magnetic moment \mathbf{M}_z along the $+z$ -axis, whereas the negative DC bias could trigger the
 183 magnetization switching as long as the reversed \mathbf{B}_{SO} overcomes the intrinsic magnetic anisotropy field
 184 \mathbf{B}_K). On the other hand, the application of an opposite $\mathbf{B}_x = -0.09$ T changes the initial condition of \mathbf{M} ,
 185 and the observation of the clockwise R_{xy} - I_{DC} hysteresis loops (red triangles in **Fig. 4c**) are in accordance
 186 with the same damping-like SOT chirality, hence confirming the deterministic switching scenario.

187 Most intriguingly, the (B_x -fixed, I_{DC} -dependent) anomalous Hall data in **Fig. 4c** discloses a dramatic
 188 reduction of the threshold switching current level I_{sw} when the top CrTe₂ layer thickness d decreases
 189 from 21 ML (17.5 mA) to 5 ML (7.5 mA) at $T = 120$ K. Equivalently, it means that the dynamic power
 190 dissipation P_{sw} can be reduced by up to 54% with appropriate bilayer structural engineering (**Fig. 4d**).
 191 To appreciate such a positive I_{sw} - d correlation, it is recalled that the reduced dimensionality of the
 192 CrTe₂ film would not only weaken its perpendicular magnetic anisotropy (**Fig. 3**), but also make the
 193 thinner FM layer more insulating so that a larger portion of charge current is regulated inside the Bi₂Te₃
 194 channel. Governed by the SOT operational principle that the modulation of the CrTe₂ FM order mainly
 195 relies on the competition/balancing between the torques exerted by the effective fields^{33, 36}, it can
 196 therefore be concluded that a lower DC current can meet the magnetization switching requirement of
 197 $|\gamma \cdot \mathbf{M} \times \mathbf{B}_{SO}| > \tau_K$ (where γ is the gyromagnetic ratio, and τ_K is the torque exerted by PMA) thanks to
 198 the attenuated \mathbf{B}_K and higher I_{TI}/I_{DC} ratio in the Bi₂Te₃/CrTe₂ (5 ML)-based SOT device. By further
 199 subtracting the shunting current via the parallel two-channel model (see Supplementary Section 4), the
 200 critical current density available for the charge-to-spin conversion is found to stay at $J_{TI, c} = 2.64 \times 10^6$
 201 A·cm⁻² as long as the bottom CrTe₂ layer exceeds 9 ML, while it drops to 1.93×10^6 A·cm⁻² for the $d =$
 202 5 ML case, again highlighting the unique advantage of vdW FMs in the 2D limit. Finally, we have
 203 evaluated the reliability of the SOT devices fabricated on the same Bi₂Te₃/CrTe₂ (5 ML) wafer. As

204 summarized in **Fig. 4e**, the current-induced R_{xy} loops for devices randomly picked from five different
205 regions essentially coincide with each other, and the device-to-device variation of I_{sw} is no more than
206 2.5%. Furthermore, the transition between the high- and low-resistance states in response to the
207 alternating positive/negative input current pulses always maintain the identical square-wave-like contour
208 without any distortion after 5×10^4 writing cycles (**Fig. 4f**), thus implying a high endurance of the tested
209 SOT device.

210

211 **Conclusion**

212 In conclusion, we have achieved the epitaxial growth of uniform 1T-CrTe₂ films on a wafer-scale by
213 MBE, and established a vdW integration strategy that allows for the *in-situ* construction of Bi₂Te₃/CrTe₂
214 heterostructures. Endorsed by the co-existence of the intrinsic PMA, atomically-sharp interfaces, and
215 strong SOC, we showcase the compelling SOT device performance of this simple bilayer stack with
216 lower switching power than the heavy metal-based FM multi-layer systems (green bars in **Fig. 4g**³⁷⁻⁴⁰).
217 Moreover, its tunable vdW ferromagnetism makes CrTe₂ a competitive building block to directly pair
218 with topological quantum materials without invoking an additional PMA-assisted layer (orange bars in
219 **Fig. 4g**^{34, 35, 40-43}). The design rule inaugurated in our work may expedite the search for new 2D vdW
220 FMs-based heterostructures, which further enables large-scale vdW material synthesis and feasible
221 spintronic device applications.

222

223 **Methods**

224 **Sample Fabrication and Structural Characterizations:** Wafer-scale CrTe₂ thin films and Bi₂Te₃/CrTe₂
225 heterostructures were grown on 2-inch Al₂O₃(0001) substrates by MBE in a vacuum of 1×10^{-10} mbar.
226 Prior to the sample growth, the Al₂O₃ substrate was pre-annealed at 600 °C in order to remove any

227 absorbed contamination. During the MBE growth, the growth temperature for CrTe₂ and Bi₂Te₃ was
228 kept at 200 °C, and the sample manipulator was constantly rotated to ensure uniformity; high-purity Cr
229 and Bi atoms were evaporated from standard Knudsen cells, while the Te atoms were evaporated by a
230 thermal cracker cell. A beam flux monitor was used to measure the flux ratio, and RHEED was used to
231 monitor the real-time growth process. After sample growth, slices of CrTe₂ with different crystal
232 orientations were milled out using the FIB technique (TESCAN LYRA3 FIB-SEM, TESCAN, Czech
233 Republic), and a probe aberration-corrected scanning transmission electron microscopy (Cs-STEM,
234 Themis Z G2 300, FEI, USA) was employed to resolve the crystal structure. The STEM was equipped
235 with energy-dispersive X-ray analysis (EDX, Bruker Super-X, Bruker, USA), allowing for the
236 determination of the Cr-to-Te stoichiometric ratio. Additionally, X-ray diffraction and reflectivity were
237 used to confirm the lattice constant and to calibrate the thickness.

238

239 ***Device Fabrication and Transport Measurements:*** The CrTe₂ thin films were etched into a six-probe
240 Hall bar geometry with typical channel size of $2 \times 1 \text{ mm}^2$. The electrodes were made by welding small
241 pieces of indium onto the contact areas. The magneto-transport measurements were performed in a He⁴
242 refrigerator (Oxford Teslatron PT system). Multiple lock-in amplifiers and Keithley source meters (with
243 an excitation AC current amplitude of $I = 1 \text{ }\mu\text{A}$) were applied to the sample, and the temperature,
244 magnetic field, and lock-in frequency served as the experimental variables. For the SOT-driven
245 magnetization switching measurements, the cross-bar patterns of the CrTe₂/Bi₂Te₃ heterostructures were
246 prepared by a standard photo-lithography process, and the Ti (15 nm)/Au (150 nm) electrodes were
247 defined by e-beam evaporation. After device fabrication, a 2-ms writing current pulse was applied by
248 Keithley 6221 while another 2-ms reading current pulse was applied thereafter to measure the R_{xy} value
249 by Keithley 2182.

250

251 ***XAS and XMCD measurements:*** Element-specific X-ray absorption spectroscopy (XAS) and X-ray
252 magnetic circular dichroism (XMCD) measurements were performed on beamline I06 at the Diamond
253 Light Source (Oxfordshire, UK), allowing for the probing of the magnetic ground state of the CrTe₂
254 layers. The base temperature was 2 K and a magnetic field of ± 6 T was applied along the surface
255 normal direction (out-of-plane). The spectroscopic data was acquired in total-electron-yield detection
256 mode which has an 1/e sampling depth of ~ 5 nm⁴⁴. The XAS spectra were recorded at the Cr *L*_{2,3} edges
257 between 560 and 595 eV. The XMCD results were obtained by taking the difference between two XAS
258 spectra with the helicity vector of the circularly polarized X-rays parallel and antiparallel to the
259 magnetic field, respectively.

260

261 ***Density Functional Theory Calculations:*** The *ab initio* calculations were performed within the
262 framework of density functional theory (DFT) as implemented in the Vienna *ab initio* simulation
263 package (VASP)⁴⁵, with the exchange-correlation functional considered in the generalized gradient
264 approximation of the Perdew-Burke-Ernzerhof⁴⁶ method. A plane-wave basis set was used with a kinetic
265 energy cutoff of 500 eV. The *k*-meshes of 11 \times 11 \times 1 for the monolayers and slabs (including 4, 5, 7, and
266 8 ML) and 11 \times 11 \times 7 for the bulk CrTe₂ were applied. To account for the correlation effect of the
267 transition metal element Cr, the GGA+*U* functional with varied *U* values for the *d*-orbitals of Cr were
268 adopted. The spin-orbital coupling was considered self-consistently in this work. The intrinsic
269 anomalous Hall conductivity were evaluated based on the maximally localized Wannier functions⁴⁷ as
270 obtained through the VASP2WANNIER90⁴⁸ interfaces in a non-self-consistent calculation, and
271 calculated on *k*-meshes of 1001 \times 1001 \times 1 for the monolayer, 601 \times 601 \times 1 for the slabs, and 301 \times 301 \times 301
272 for the bulk by the WannierTools package⁴⁹.

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393 **Author Contributions**

394 X.F.K., and Q.Y. conceived and supervised the study. X.Q.L. and Q.Y. grew the samples and performed
395 the X-ray measurements. X.Q.L. conducted the transport measurements. X.Q.L. and Q.Y. analyzed the
396 transport and characterization data. L.G. and Y.X. conducted the TEM measurements and theoretical
397 calculations, respectively. D.B., G.v.d.L., and T.H. performed the XAS/XMCD measurements. X.Q.L.,
398 Y.X., Q.Y., and X.F.K. wrote the manuscript. All authors discussed the results and commented on the
399 manuscript.

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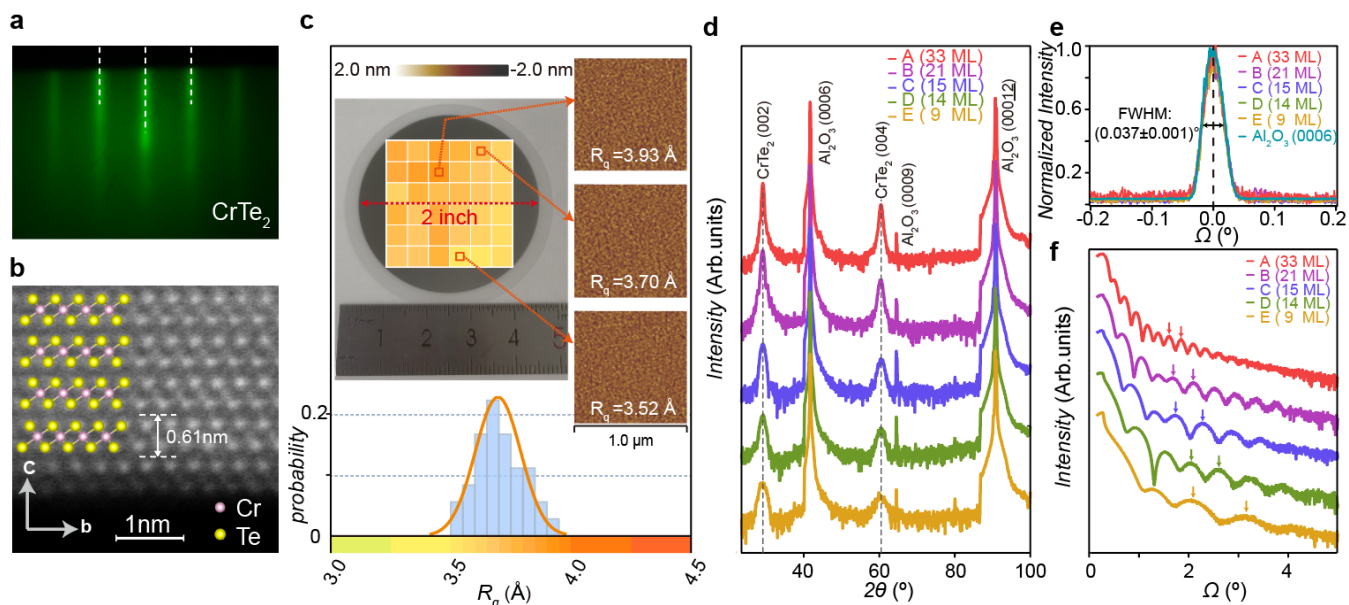
401 **Competing interests**

402 The authors declare no competing interests.

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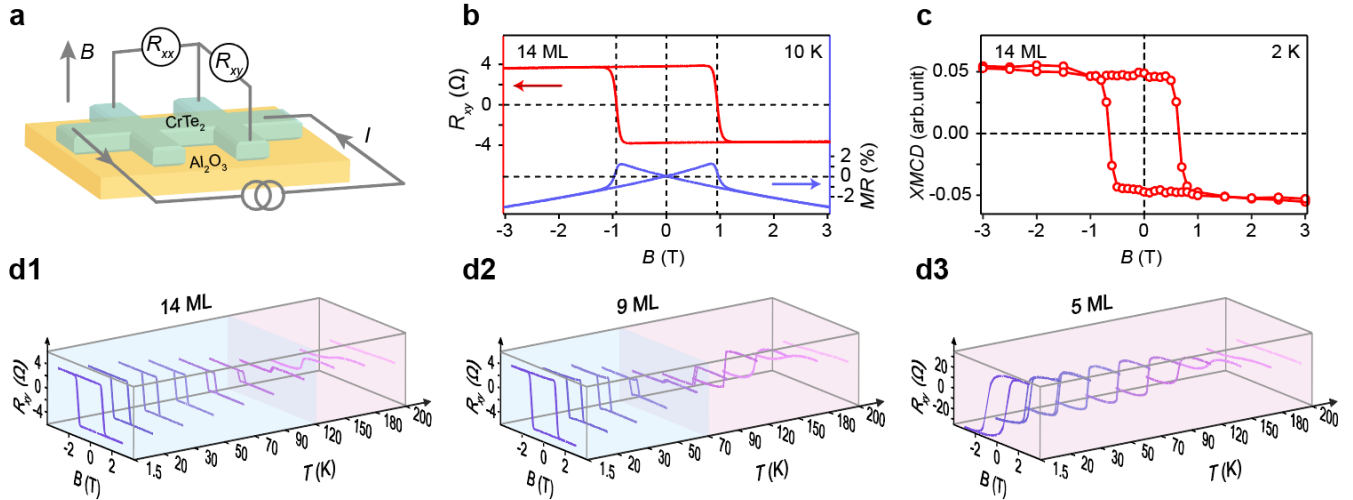
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407 **Fig. 1. Epitaxial growth of wafer-scale 1T-CrTe₂ thin films.** **a**, *in-situ* RHEED pattern of the CrTe₂
 408 film grown on the Al₂O₃ substrate. The spacing between the two first-order streaks (dashed white lines)
 409 is used to deduce the in-plane lattice constant. **b**, Cross-sectional High-resolution STEM image of the
 410 MBE-grown CrTe₂ sample. The atomic arrangement is consistent with the crystal structure of 1T-CrTe₂.
 411 The Cr and Te atoms are labeled as pink and yellow spheres, respectively. **c**, AFM images were taken at
 412 36 different positions across the 2-inch 9 ML CrTe₂ wafer, and the statistical histogram of the measured
 413 root-mean-square roughness R_q confirms the homogeneous surface morphology. **d**, The XRD spectra of
 414 CrTe₂ films ranging from 9 to 33 ML. **e**, Identical rocking curves of the CrTe₂ (002) film peaks with the
 415 same FWHM value as the Al₂O₃ substrate highlight the very high crystalline quality of the CrTe₂ films.
 416 **f**, XRR data of the thickness-dependent CrTe₂ films with oscillatory Kiessig fringes. The spacing
 417 between neighboring interference peaks (labeled as arrows) is inversely correlated to the film thickness.

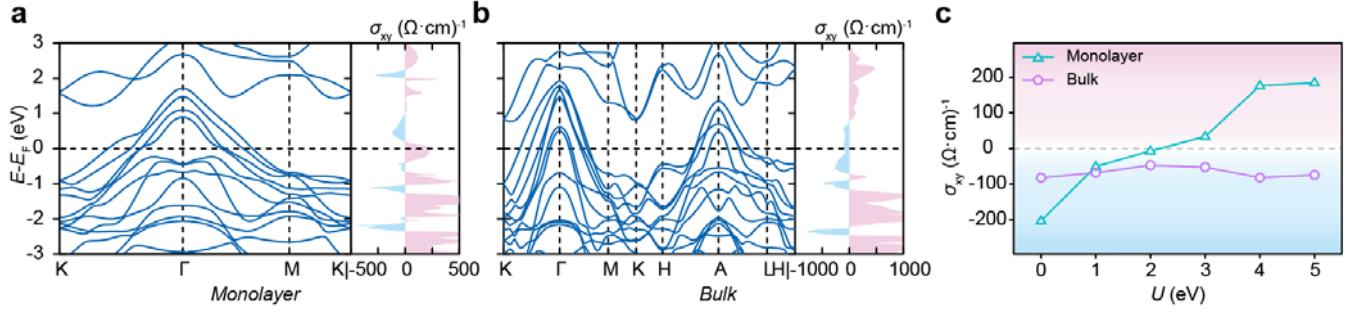
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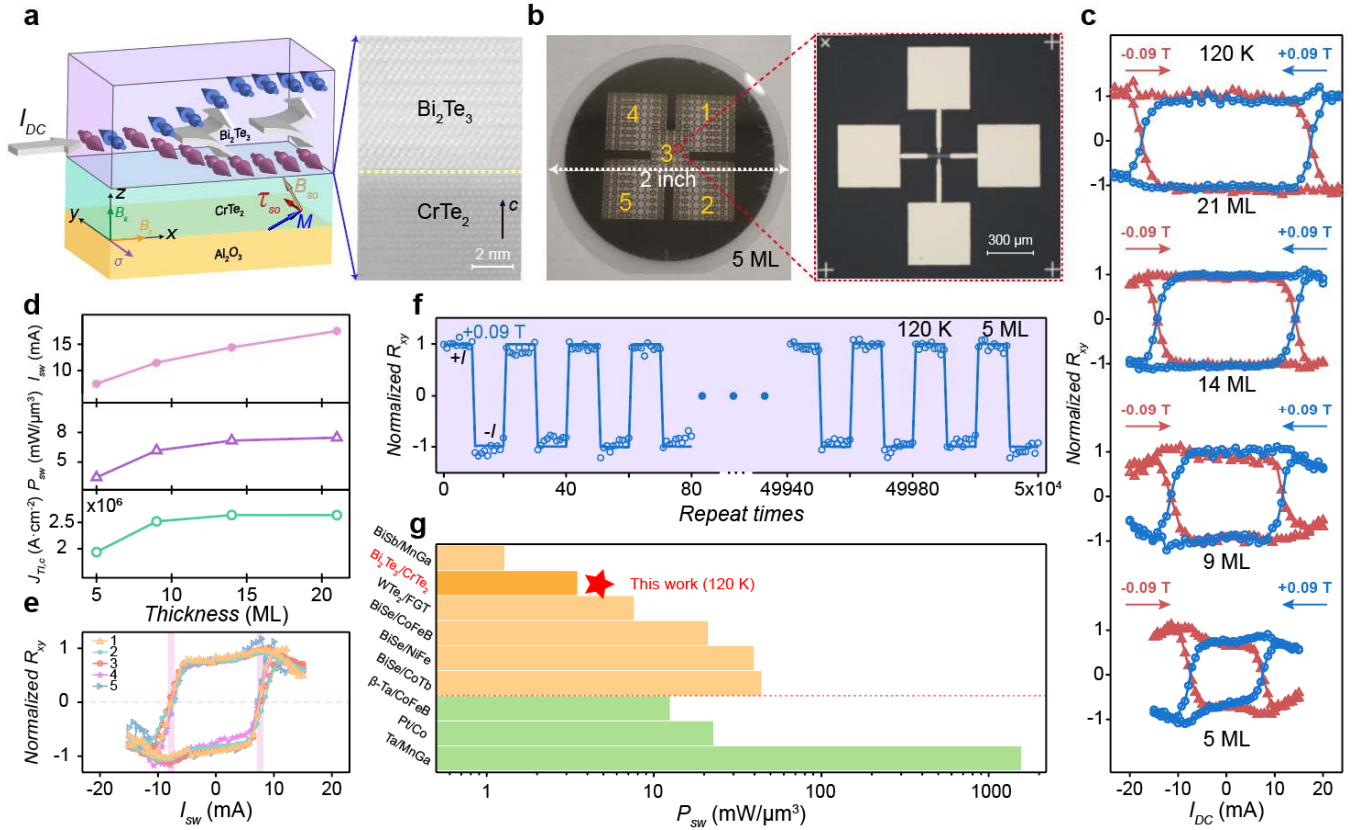
420 **Fig. 2. Thickness- and temperature-driven anomalous Hall effect in the MBE-grown CrTe₂ thin**
 421 **films. a,** Schematic of a six-probe Hall bar and the setup of the magneto-transport measurement. **b,** The
 422 anomalous Hall resistance (R_{xy}) and magnetoresistance (MR) curves of the 14 ML CrTe₂ film at $T = 10$
 423 K. **c,** The square-shaped XMCD hysteresis loop taken at the Cr L_3 edge manifests the robust long-range
 424 magnetic moment with perpendicular magnetic anisotropy. **d1-d3,** Temperature-dependent AHE results
 425 in three CrTe₂ samples with film thickness of 14 ML (**d1**), 9 ML (**d2**), and 5 ML (**d3**), respectively. The
 426 AHE polarity of the bulk-type CrTe₂ samples is reversed in the high-temperature region, whereas such
 427 negative-to-positive transition is absent in the ultra-thin case.

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430 **Fig. 3. Capturing the dimensionality effect in the vdW FM CrTe₂ system by density-functional**
 431 **theory calculations. a-b,** Electronic band structure (left panel) and corresponding intrinsic anomalous
 432 Hall conductivity σ_{xy} (right panel) of monolayer (a) and bulk-form 1T-CrTe₂ (b) with the onsite
 433 Coulomb potential of $U = 4$ eV. c, Evolution of the anomalous Hall conductivity with respect to the
 434 Coulomb potential. The negative σ_{xy} of the bulk CrTe₂ shows little variation, while the orbital
 435 hybridization in the 2D limit modifies the Berry curvature and triggers the AHE polarity switching in the
 436 monolayer case.



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438 **Fig. 4. Tunable SOT-driven magnetization switching in Bi₂Te₃/CrTe₂ heterostructures.** **a**,
 439 Schematic of the SOT mechanism in the Bi₂Te₃/CrTe₂ bilayer stack. Right panel: the HR-STEM image
 440 discloses an atomically sharp Bi₂Te₃/CrTe₂ hetero-interface which warrants efficient spin injection. **b**,
 441 Optical image of the patterned cross-bar SOT device arrays on the 2-inch wafer. **c**, Current-induced
 442 magnetization switching in four Bi₂Te₃/CrTe₂ samples with different CrTe₂ layer thicknesses of 21, 14,
 443 9, and 5 ML (from top to bottom). **d**, Summary of the critical switching current I_{sw} , dynamic power
 444 P_{sw} , and threshold current density $J_{TL,c}$ as a function of the CrTe₂ thickness. **e**, Highly-repeatable
 445 switching loops measured from five randomly-selected devices of the SOT device array. **f**, Endurance
 446 test of the Bi₂Te₃/CrTe₂(5 ML) device. The square-wave read-out signal does not show any distortion
 447 even after 5×10^4 write/read cycles. **g**, Benchmark the performance of the Bi₂Te₃/CrTe₂-based SOT
 448 device with other magnetic bilayer systems.